

Form PTO-1449

Sheet 1 of 1

Document Number

Application Number

54487

INFORMATION DISCLOSURE CITATION
IN AN APPLICATION

Applicant Sterzel

Filing Date

Group Art Unit

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U.S. PATENT DOCUMENTS						
Exam. Init.	Document Number	Date	Name	Class	Sub- Class	Filing Date

FOREIGN PATENT DOCUMENTS						
	Document Number	Date	Country	Class	Sub- Class	Filing Date

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)	
KMV	Electrochemical and Solid-State Letters (2002), 5(2), A39-A42, Kavan et al.

EXAMINER	/Kallambella Vijayakumar/	DATE CONSIDERED	09/22/2006
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INFORMATION DISCLOSURE CITATION
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Document Number
54487Applicant
STERZEL et al.Filing Date
April 22, 2004Sheet ____ of ____
Application Number
10/829,175Group Art Unit
1751

U.S. PATENT DOCUMENTS						
Exam. Init.	Document Number	Date	Name	Class	Sub-Class	Filing Date
KMV	2002/0102205	08/2002	Amatucci et al.			

FOREIGN PATENT DOCUMENTS						
	Document Number	Date	Country	Class	Sub-Class	Filing Date

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)	
KMV	Journal of Power Sources, Elsevier Sequoia S.A. Lausanne, CH, vol. 81-82, Sept. 1999, p. 352-357 is listed in the international search report in category "A".

EXAMINER	/Kallambella Vijayakumar/	09/22/2006
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